

IN THE CLAIMS

Please amend the claims to read as shown below. The claims have been rewritten in clean form with changes included. Another version of the claims, which is enclosed with this amendment on separate pages, is marked up to show the changes that have been made.

- Int. d*
B19
1. (Twice Amended) A wavemeter for determining a wavelength of an incoming optical beam comprising:
- a coarse-measuring unit for determining in a first wavelength range and with a first accuracy, a first wavelength value as representing the wavelength of the incoming optical beam,
 - a fine-measuring unit for providing a wavelength determination with a second accuracy for the incoming optical beam, wherein the wavelength determination is ambiguous within the first wavelength range but unambiguous in each of a plurality of unambiguous wavelength ranges, so that a plurality of different wavelength values correspond to a measuring value as measured by the fine-measuring unit for the incoming optical beam and wherein the second accuracy is higher than the first accuracy,
 - an evaluation unit for determining a second wavelength range covering the first wavelength value, and for determining a second wavelength value as the one of the plurality of different wavelength values that corresponds to the measuring value in the second wavelength range, and
 - output means for providing the second wavelength value as measuring result of the wavemeter representing the wavelength of the incoming optical beam,
 - wherein the coarse-measuring unit comprises one or more materials having a wavelength-dependency of reflection and/or transmission.

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2. (Twice Amended) The wavemeter of claim 1, wherein the fine-measuring unit comprises means for providing a periodic wavelength dependency, the periodicity of the wavelength-dependency being larger than a measuring fault or inaccuracy of the coarse-measuring unit.

3. (No Change) The wavemeter of claim 1, wherein the coarse-measuring unit comprises a dielectric coating having one or more layers of materials, chosen from the group of MgF_2 , SiO_2 , or CeF_3 , with different refractive indices and thickness.
 4. (No Change) The wavemeter of claim 1, wherein the coarse-measuring unit comprises a glass plate with a dielectric coating on one side and an anti-reflection coating on another side, thus representing a wavelength-dependent beamsplitter.
 5. (No Change) The wavemeter of claim 1, further comprising an absolute-measuring unit having unambiguous wavelength properties.
 6. (No Change) A method for determining a wavelength of an incoming optical beam comprising:
 - determining in a first wavelength range and with a first accuracy a first wavelength value as representing the wavelength of the incoming optical beam,
 - providing a wavelength determination with a second accuracy for the incoming optical beam, wherein the wavelength determination is ambiguous within the first wavelength range but unambiguous in each of a plurality of unambiguous wavelength ranges, so that a plurality of different wavelength values correspond to a measuring value as measured for the incoming optical beam, and wherein the second accuracy is higher than the first accuracy,
 - determining a second wavelength range covering the first wavelength value,
 - determining a second wavelength value as the one of the plurality of different wavelength values that corresponds to the measuring value in the second wavelength range, and
 - providing the second wavelength value as measuring result representing the wavelength of the incoming optical beam.
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- 8 20 7. (Twice Amended) The method of claim 6, further comprising:

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providing a reference measurement from an absolute-measuring unit having unambiguous and absolutely known wavelength properties.

8. (No Change) The method of claim 7, wherein providing a reference measurement is executed prior to determining in a first wavelength range and with a first accuracy a first wavelength value, for calibration before an actual measurement.

9. (No Change) The method of claim 7, wherein providing a reference measurement comprises:

sweeping an input signal over a wavelength range wherein the absolute-measuring unit has at least one of the unambiguous and absolutely known wavelength properties,

analyzing a measuring result derived from sweeping an input signal over a wavelength range, together with a measuring result derived from determining in a first wavelength range and with a first accuracy, a first wavelength value, and

providing a wavelength determination with a second accuracy for the incoming optical beam, for determining a relation between the unambiguous and absolutely known wavelength properties and the derived measuring result(s).

10. (No Change) The method of claim 7, wherein providing a reference measurement is executed for calibrating a wavemeter, and/or for adjusting measuring results as provided by the wavemeter, said wavemeter comprising:

a coarse-measuring unit for determining in a first wavelength range and with a first accuracy a first wavelength value as representing the wavelength of the incoming optical beam,

a fine-measuring unit for providing a wavelength determination with a second accuracy for the incoming optical beam, wherein the wavelength determination is ambiguous within the first wavelength range but unambiguous in each of a plurality of unambiguous wavelength ranges, so that a plurality of different wavelength values correspond to a measuring value as measured by the fine-measuring unit for the incoming optical beam and wherein the second accuracy is higher than the first accuracy,

an evaluation unit for determining a second wavelength range covering the first wavelength value, and for determining a second wavelength value as the one of the plurality of different wavelength values that corresponds to the measuring value in the second wavelength range, and

output means for providing the second wavelength value as measuring result of the wavemeter representing the wavelength of the incoming optical beam,

wherein the coarse-measuring unit comprises one or more materials having a wavelength-dependency of reflection and/or transmission.

11. (No Change) The method of claim 7, wherein determining a second wavelength range covering the first wavelength value comprises determining the second wavelength range as a wavelength range around the first wavelength value.

12. (No Change) The method of claim 11, wherein the second wavelength range is determined by adding and subtracting a value.

13. (No Change) A software product, for executing a method for determining a wavelength of an incoming optical beam, when run on a data processing system such as a computer, said method comprising:

determining in a first wavelength range and with a first accuracy a first wavelength value as representing the wavelength of the incoming optical beam,

providing a wavelength determination with a second accuracy for the incoming optical beam, wherein the wavelength determination is ambiguous within the first wavelength range but unambiguous in each of a plurality of unambiguous wavelength ranges, so that a plurality of different wavelength values correspond to a measuring value as measured for the incoming optical beam, and wherein the second accuracy is higher than the first accuracy,

determining a second wavelength range covering the first wavelength value,

determining a second wavelength value as the one of the plurality of different wavelength values that corresponds to the measuring value in the second wavelength range, and

providing the second wavelength value as measuring result representing the wavelength of the incoming optical beam.

14. (No Change) The software product of claim 13, wherein said software product is stored on a data carrier.

15. (No Change) The wavemeter of claim 1, further comprising
an absolute-measuring unit having unambiguous wavelength properties, including absolutely known transmission features provided by a gas absorption cell.

16. (Amended) The method of claim 6, further comprising:
providing a reference measurement from an absolute-measuring unit having unambiguous and absolutely known wavelength properties, including absolutely known transmission features provided by a gas absorption cell.

B2 17. (Amended) The method of claim 7, wherein providing a reference measurement is executed concurrently with determining in a first wavelength range and with a first accuracy, a first wavelength value, and providing a wavelength determination with a second accuracy for the incoming optical beam, for providing a continuous calibration.

18. (Amended) The method of claim 7, wherein providing a reference measurement is executed concurrently with determining in a first wavelength range and with a first accuracy, a first wavelength value, or providing a wavelength determination with a second accuracy for the incoming optical beam, for providing a continuous calibration.

19. (No Change) The method of claim 7, wherein providing a reference measurement comprises:

sweeping an input signal over a wavelength range wherein the absolute-measuring unit has at least one of the unambiguous and absolutely known wavelength properties,

analyzing a measuring result derived from sweeping an input signal over a wavelength range together with a measuring result derived from determining in a first

wavelength range and with a first accuracy, a first wavelength value, or providing a wavelength determination with a second accuracy for the incoming optical beam, for determining a relation between the unambiguous and absolutely known wavelength properties and the derived measuring result(s).

20. (No Change) The method of claim 11, wherein the second wavelength range is determined by adding and subtracting a value corresponding to half of the period of the unambiguous wavelength range covering the first wavelength value, to and from the first wavelength value.